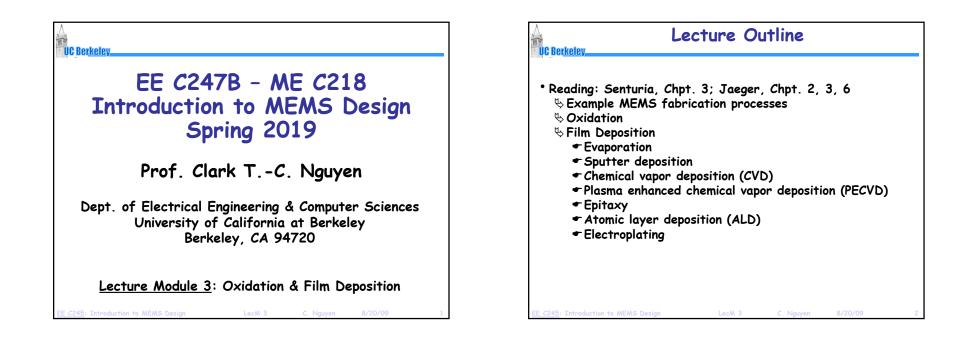
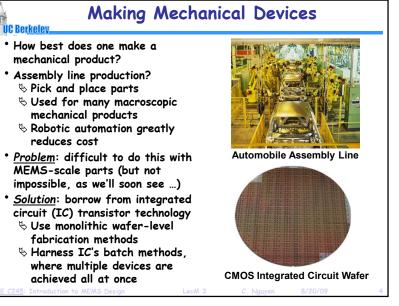
<u>EE 247B/ME218</u>: Introduction to MEMS Design Lec5m2: Oxidation & Film Deposition

1







Copyright @ 2019 Regents of the University of California

## <u>EE 247B/ME218</u>: Introduction to MEMS Design <u>Lec5m2</u>: Oxidation & Film Deposition

